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IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :

ATSUMI YAMAGUSHI, ET AL.

: EXAMINER: DEO, DUY VU
NGUYEN

SERIAL NO: 09/915,396

: GROUP ART UNIT: 1765

RCE HEREWITH

FILED:

FOR: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

do not enter (P)

AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS
ALEXANDRIA, VA 22313

SIR:

In response to the Office Action dated July 24, 2003, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Amendments to the Drawings begin on page 9 of this paper and include attached replacement sheets (4).

Remarks/Arguments begin on page 10 of this paper.